PTO-1449 REPRODUCED	ATTORNEY DOCKET NO. 2251.2002-009	APPLICATION NO.				
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	APPLICANT Tzvi Avnery					
September 19, 2003	FILING DATE	GROUP				
(Use several sheets if necessary)						

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Ī	AB	4,324,759	04/13/1982	Aoki et al.				
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	AK	5,457,269	10/10/1995	Schonberg				
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Ŋ	AC3	4,752,450	06/21/1988	Dietrich et al.				

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10	AL	GB 2 173 779 A	22/10/1986	United Kingdom	
	AM	63302924	09/12/1988	· Japan (Abstract Only)	
	AN	EP 0 579 105 A1	19/01/1994	EPO	
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Q	AR	Tian, C., and Vidal, C.R., "Single to Quadruple Ionization of CO <sub>2</sub> Due to Electron Impact," Phys. Rev. A, 58(5): 3783-3795 (1998).					
b	AS	Darici, Y., et al., "Electron Beam Dissociation of CO and CO <sub>2</sub> on ZnS Thin Films," J. Vac. Sci. Technol. A, 17(3), 692-697 (1999).					
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